

OCT 28 2005

PATENT APPLICATION  
RESPONSE UNDER 37 CFR § 1.114  
EXAMINING GROUP 2600

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re App:	BOUTAGHOU et al	Date:	October 28, 2005
S.N.:	09/905,037	Docket No.:	STL 9721.00
Filed:	13 July 2001	Examiner:	Lan Vinh
For:	METHOD FOR TOPOGRAPHICAL PATTERNING OF A DEVICE	Art Unit:	1765

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REQUEST FOR CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450RECEIVED  
OIPE/IAP

OCT 31 2005

Dear Sir:

Under C.F.R. §1.114, it is respectfully requested that this application be accorded the benefits of Continued Examination in order to enter the Amendment filed herewith.

Please charge Deposit Account No. 50-0372 in the amount of \$790.00 to cover the required fee for a large entity.

005-LWONDIM1 00000010-500372 09905037  
801 790.00 DA

10/31/2005 LWONDIM1 00000010 09905037

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